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CAU/1765 DU STONE IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of John D. Holder Serial No. 10/002,862 Filed November 15, 2001 Confirmation No. 4783

Art Unit 1765

INTERMITTENT FEEDING TECHNIQUE FOR INCREASING THE MELTING RATE OF POLYCRYSTALLINE SILICON

March 5, 2002

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS,

SIR:

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicant submits copies of the references listed on the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the aboveentitled application and to be made of record therein.

Respectfully submitted,

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	Complete if Known		
Application Number	10/002,862		
Filing Date	November 15, 2001		
Confirmation Number	4783		
First Named Inventor	John D. Holder		
Group Art Unit	1765 MAP		
Examiner Name	C, 42		
Attorney Docket No.	MEMC 3003		
	Filing Date Confirmation Number First Named Inventor Group Art Unit Examiner Name		

		U	.S. PATENT	DOCUMENTS	
	Cite No.1	U.S. Patent Document			
Examiner Initials*		Number	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
	1	5,059,410		Boone et al.	10/22/1991
_	2	5,087,321		Kamio et al.	02/11/1992
	3	5,087,429		Kamio et al.	02/11/1992
	4	5,126,114		Kamio et al.	06/30/1992
<u></u>	5	5,152,433		Mohri	10/06/1992
	6	5,462,010		Takano et al.	10/31/1995
, 	7	5,588,993		Holder	12/31/1996
	8	5,858,087		Taguchi et al.	01/12/1999
	9	5,902,395		Nagai et al.	05/11/1999
	10	5,919,303		Holder	07/06/1999
	11	6,110,272		Aikawa et al.	08/29/2000
Examiner				Date	

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, D.C. 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

PTÖ/SB/08A	Complete if Known		
INFORMATION DISCLOSURE	Application Number	10/002,862	
STATEMENT BY APPLICANT	Filing Date	November 15, 2001	
(use as many sheets as necessary)	Confirmation Number	4783	
OIPEZO	First Named Inventor	John D. Holder	
MAR 0 5 2002	Group Art Unit	1765	
	Examiner Name	TO.	
Sheet 2 TRACE 2	Attorney Docket No.	MEMC 3003 MAP ,	

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			FOR	EIGN PATE	ENT DOCUMENTS	0)
Foreign Pa		oreign Patent Do	ocument				
Examiner Initials*	Cite No.1	Office	Number⁴	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Τ6
	12	EP	0 406 824	A1	Mohri	09/01/1991	
	13	DE	42 01 546	A1	Klöpsch et al.	07/23/1992	
		OTH	IER ART - N	ON PATEN	T LITERATURE DOCUMEN	TS	
Examiner Initials*	Cite No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ⁶	

1	,	 	
	Examiner	Date	
	Signature	Considered	

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